

JAN 26 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jin, et al.

Application No.: 10/805,718

Filed: 3/22/2004

Title: THIN FILM RESISTOR STRUCTURE AND
METHOD FOR FORMING THIN FILM RESISTOR
STRUCTUREArt Unit:
2832Examiner:
Trung Q. Dang

Attorney Docket No.: 1766A

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

O.K TO ENTER

Amendment After AllowanceT.D
3/22/06

Dear Sir:

Applicants respectfully request that the Examiner enter the following amendment
and consider the following remarks.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.